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Patent

Attorney's Docket No. 030681-332

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
)
Hae-seok PARK et al.) Group Art Unit: Unassigned
)
Application No.: New Application) Examiner: Unassigned
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Filed: Herewith)
)
For: MICROMIRROR ACTUATOR)

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Prior to examination on the merits, kindly amend the above-captioned application as follows:

IN THE SPECIFICATION:

Kindly add the following paragraph on page 1, after the title of the invention and before the "Background of the Invention," -- Priority is claimed to Patent Application number 2000-73483 filed 5 December 2001 in the Republic of Korea, herein incorporated by reference.--

Kindly replace the paragraph beginning at page 4, line 20-30 with the following:

A groove 50 is formed to a predetermined depth in the substrate 10, and an inclined contact surface 51 which will contact the lower bottom surface of the mirror 30 is formed